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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**Applicant** 

Shigeki SAKAI et al.

Serial No.

(Not yet known)

Filed

(Currently herewith)

For

SEMICONDUCTOR NONVOLATILE STORAGE

ELEMENT AND METHOD OF FABRICATING

THE SAME

Group Art Unit

(Not yet known)

Examiner

(Not yet known)

Assistant Commissioner for Patents Washington, D.C. 20231

## PRELIMINARY AMENDMENT

Sir:

Preliminary to examination, please amend this application as follows:

## IN THE CLAIMS:

Please substitute for corresponding pending claims the claims as shown rewritten below with amendments effected therein. Appendix II is attached hereto having marked versions of said claims with amendments indicated by brackets and underlining.